

SUGHRUE MION, PLLC

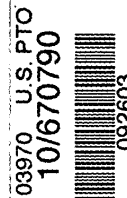
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September 26, 2003

MAIL STOP PATENT APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

2100 Pennsylvania Avenue, NW
Washington, DC 20037-3213
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Re: Application of Katsuhisa OHZEKI
METHOD OF PRODUCING METAL PARTICLES, AND METAL OXIDE
OBTAINED FROM THE PARTICLES
Assignee: FUJI PHOTO FILM CO., LTD.
Our Ref. Q77620

Dear Sir:

Attached hereto is the application identified above comprising eighty-two (82) sheets of the specification, including the claims and abstract and seven (7) sheets of drawings. The requisite U.S. Government Filing Fee, a copy of the executed Declaration and Power of Attorney, and a copy of the executed Assignment will be filed at a later date.

The Government filing fee is calculated as follows:

Total claims	20 - 20	=		x	\$18.00	=	\$0.00
Independent claims	4 - 3	=	1	x	\$84.00	=	\$84.00
Base Fee							\$750.00
							\$834.00

TOTAL FEE

Priority is claimed from:

Country	Application No	Filing Date
Japan	2002-287810	September 30, 2002
Japan	2002-287824	September 30, 2002

The priority documents will be filed at a later date.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

By: Darryl Mexic
Darryl Mexic
Registration No. 23,063

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